

AF
IHW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

BRIAN VIALPANDO ET AL.

Serial No. 10/727,392 (TI-35829)

Filed December 4, 2003

For: A THIN FILM RESISTOR STRUCTURE AND METHOD
OF FABRICATING A THIN FILM RESISTOR STRUCTURE

Art Unit 1765

Examiner Shamim Ahmed

Customer No. 23494

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING OR TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that the attached document is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to Director of the United States Patent and Trademark Office, P.O. Box 1450,, Alexandria, VA 22313-1450 or is being facsimile transmitted on the date indicated below:

4-7-06
[Signature]

Jay M. Cantor, Reg. No. 19,906

AMENDMENT UNDER 37 C.F.R. 1.116

In response to the Office action dated March 31, 2006, the following remarks are
presented: